Searcn	Notes

Application/Control No.	Applicant(s)/Patent und Reexamination	er
10/808,354	TANAKA ET AL.	
Examiner	Art Unit	
Toan Ton	2871	

SEARCHED				
Class	Subclass	Date	Examiner	
349	125	4/20/2005	TTON	
	130			

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
	<u></u>			

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
EAST Icd oblique evaporat\$/vapor inorganic silicon oxide/sio angle aligning/aligment orientating/orientation thick/thickness	4/20/2005	TTON
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